



Serial No. 10/717,934

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Amendment dated January 3, 2006

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of

Makoto Terui et al.

Group Art Unit: 2823

Serial No.: 10/717,934

Examiner: W. Brewster

Filed: November 21, 2003

Confirm No.: 7542

For: METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE HAVING A  
HEAT RADIATION LAYER

*Entered  
w/ RCE  
ctd 1/3/06  
Dull  
3/3/06*

**AMENDMENT**

U.S. Patent and Trademark Office  
Customer Window, Mail Stop RCE  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Date: January 3, 2006  
(Tuesday after Federal Holiday)

Sir:

In response to the Final Office Action dated September 2, 2005, the period for response having been extended one (1) month to January 2, 2006, the following amendments and remarks are respectfully submitted, concurrently along with a Request for Continued Examination (RCE), in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.